| L Number | Hits | Search Text | DB | Time stamp |
|-------------|------|---|---|---------------------|
| 1 | 121 | <pre>(no or (nitric with oxide)) and cvd and (nitrogen with dop\$3 with oxide) and (thermal adj oxidation)</pre> | USPAT; US-PGPUB; EPO; JPO; | 2004/01/08 15:58 |
| 2 | 108 | ((no or (nitric with oxide)) and cvd and (nitrogen with dop\$3 with oxide) and (thermal adj oxidation)) and | DERWENT USPAT; US-PGPUB; EPO; JPO; | 2004/01/08 |
| 3 | 100 | (@ad<20011012 or @rlad<20011012) ("no".u/c. or (nitric with oxide)) and cvd and (nitrogen with dop\$3 with oxide) and (thermal adj oxidation) | DERWENT USPAT; US-PGPUB; EPO; JPO; | 2004/01/08 |
| 4 | 93 | (("no".u/c. or (nitric with oxide)) and cvd and (nitrogen with dop\$3 with oxide) and (thermal adj oxidation)) and | DERWENT USPAT; US-PGPUB; EPO; JPO; | 2004/01/08 18:15 |
| 5 | 88 | (@ad<20011012 or @rlad<20011012) ("no".u/c. or (nitric with oxide)) and cvd and ((thermal adj oxidation) same (thermal adj nitridation)) | DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/01/08 18:15 |
| 6 | 85 | (("no".u/c. or (nitric with oxide)) and cvd and ((thermal adj oxidation) same (thermal adj nitridation))) and | USPAT; US-PGPUB; EPO; JPO; | 2004/01/08 18:32 |
| 7 | 2 | (@ad<20011012 or @rlad<20011012) ("no".u/c. or (nitric with oxide)) and cvd and ((thermal adj oxidation) same (thermal adj nitridation) same (gate adj oxide)) | DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/01/08 18:32 |
| 8 | 31 | ("no".u/c. or (nitric with oxide)) and cvd and ((thermal adj oxidation) same (gate adj oxide)) and (thermal adj nitridation) | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/01/08 18:32 |
| 9 | 30 | <pre>(("no".u/c. or (nitric with oxide)) and cvd and ((thermal adj oxidation) same (gate adj oxide)) and (thermal adj nitridation)) and (@ad<20011012 or @rlad<20011012)</pre> | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2004/01/08 18:32 |
| - | 355 | (gate with oxide) and (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd | USPAT; EPO; JPO; DERWENT | 2004/01/08 15:52 |
| - | 197 | ((gate with oxide) and (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd) and temperature and (atm or atmosphere or torr) | USPAT; EPO; JPO; DERWENT | 2002/07/30 14:02 |
| _ | 149 | (((gate with oxide) and (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd) and temperature and (atm or atmosphere or torr)) and 438/\$3.ccls. | USPAT; EPO; JPO; DERWENT | 2002/07/30 14:02 |
| - | 119 | ((((gate with oxide) and (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd) and temperature and (atm or atmosphere or torr)) and 438/\$3.ccls.) and (gate with electrode) | USPAT; EPO; JPO; DERWENT | 2002/07/30 |
| - | 145 | (gate with oxide) same (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd | USPAT; EPO; JPO; DERWENT | 2002/07/31 15:55 |
| - | 76 | ((gate with oxide) same (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd) and temperature and (atm or atmosphere or torr) | USPAT; EPO; JPO; DERWENT | 2002/07/30 14:02 |
| _ | 59 | (((gate with oxide) same (oxidiz\$3 with substrate) and (nitrid\$5 with (no or (nitric with oxide))) and cvd) and temperature and (atm or atmosphere or torr)) and 438/\$3.ccls. | USPAT; EPO; JPO; DERWENT | 2002/07/30 14:02 |

| substrate) and ((nitrid\$5 with (no or EPO; JPO; 15:1 (nitric with oxide)) same boron)) and cvd DERWENT | /07/30 1 |
|---|-------------|
| (nitric with oxide)) same boron)) and cvd DERWENT USPAT; 2002 EPO; JPO; 15:1 | 1 |
| - 17 "5650344" USPAT; 2002 EPO; JPO; 15:1 | |
| EPO; JPO; 15:1 | |
| EPO; JPO; 15:1 | /07/30 |
| | |
|) DERWENT I | 1 |
| | |
| - 14 "5403786" USPAT; 2002 | /07/31 |
| EPO; JPO; 14:1 | 6 |
| DERWENT | |
| | /07/31 |
| | |
| substrate) and (nitrid\$5 with (no or EPO; JPO; 15:5 | 1 |
| (nitric with oxide))) and cvd and one and DERWENT | |
| (gate adj electrode) | |
| - 22 (gate with oxide) same (oxidiz\$3 with USPAT; 2002 | /07/31 |
| substrate) and (nitrid\$5 with (no or EPO; JPO; 16:3 | 3 |
| (nitric with oxide))) and cvd and ono and DERWENT | • |
| | |
| ((gate adj electrode) with (silicon or | |
| polysilicon)) | |
| | /07/31 |
| substrate) and (nitrid\$5 with (no or EPO; JPO; 15:5 | 8 |
| (nitric with oxide))) and cvd and one and DERWENT | |
| ((gate adj electrode) with (silicon or | |
| | |
| polysilicon))) and tungsten | (07 (01 |
| | /07/31 |
| substrate) and (nitrid\$5 with (no or EPO; JPO; 16:5 | 6 |
| (nitric with oxide))) and cvd and one and DERWENT | |
| (((gate adj electrode) with polycide) | |
| same tungsten) | |
| | /07/31 |
| | |
| EPO; JPO; 16:5 | 6 |
| DERWENT | |
| - 3554 (nitrid\$5 with gate with oxide) and cvd USPAT; 2003 | /01/13 |
| EPO; JPO; 12:3 | |
| DERWENT | - |
| | /01/13 |
| 0 ((nitrid\$5 with gate with oxide) same USPAT; 2003 | |
| (nitirc adj oxide)) and cvd EPO; JPO; 12:3 | 3 |
| DERWENT | |
| - 5 ((nitrid\$5 with gate with oxide) same USPAT; 2003 | /01/13 |
| (nitric adj oxide)) and cvd EPO; JPO; 12:3 | 3 |
| DERWENT | _ |
| | /01/13 |
| | |
| | 5 |
| EPO; JPO; | |
| DERWENT | |
| - 0 11040681.URPN. USPAT 2003 | /01/13 |
| 14:4 | |
| 0 50000 | /01/13 |
| US-PGPUB; 16:2 | |
| | 9 |
| EPO; JPO; | |
| DERWENT | / / - |
| - 355 dry adj oxide USPAT; 2003 | /01/13 |
| US-PGPUB; 16:4 | 9 |
| EPO; JPO; | |
| DERWENT | |
| | /01/13 |
| 1 | |
| , | 1 |
| EPO; JPO; | |
| DERWENT | |
| | /01/13 |
| or "15") US-PGPUB; 17:2 | |
| EPO; JPO; | - |
| DERWENT | |
| | /01 /12 |
| | /01/13 |
| ("10" or "15")) and nitrid\$5 US-PGPUB; 17:0 | 6 |
| EPO; JPO; | |
| DERWENT | |
| | /01/13 |
| ("10" or "15")) same nitrid\$5 | |
| | ~ |
| EPO; JPO; | |
| DERWENT | |

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| _ | 8 | (gate adj oxide) with angstrom with ("10" | USPAT; | 2003/01/13 |
|---|---|---|-----------|------------|
| | | or "15") with (ultra near2 thin) | US-PGPUB; | 17:24 |
| j | | | EPO; JPO; | |
| 1 | | | DERWENT | • |